LISTING OF THE CLAIMS

- 1. (Currently Amended) An apparatus for creating a molecular array comprising: a base;
- a Z controller operably connected to the base wherein the Z controller is selectively positionable along a Z axis;
- a deposition probe removably and operably connected to the Z controller so that the deposition probe is selectively positionable along the Z axis by the Z controller;
- an X, Y controller operably connected to the base wherein the X, Y controller is selectively positionable along an X axis and a Y axis, the X, Y controller further comprising a deposition substrate operably attached thereto and wherein the movement of the X, Y controller moves the deposition substrate between a first position and a second position, the second position being operably positioned relative to located under the deposition probe; and
- an X, Y translation stage operably connected to the base wherein the X, Y translation stage is selectively positionable along an X axis and a Y axis, the X, Y translation stage further comprising a loading substrate operably attached thereto and wherein the movement of the X, Y translation stage moves the loading substrate between a first position and a second position, the second position being operably located relative to under the deposition probe.
- 2. (Original) The apparatus of claim 1 further comprising a control computer.
- 3. (Original) The apparatus of claim 2 further comprising a humidity controller operably attached to the base wherein the humidity controller controls the humidity around the deposition probe.
- 4. (Original) The apparatus of claim 3 wherein the humidity controller is operably connected to the control computer.
- 5. (Original) The apparatus of claim 1 wherein the Z controller has an approximately 200 nanometer spatial resolution along the Z axis.

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- 6. (Original) The apparatus of claim 5 wherein the X, Y controller has an approximately 20 nanometer spatial resolution along the X and Y axes.
- 7. (Original) The apparatus of claim 1 wherein the loading substrate further comprises one or more deposition materials deposited thereon.
- 8. (Original) The apparatus of claim 1 further comprising an optical microscope operably attached to the base.
- 9. (Original) The apparatus of claim 2 further comprising a force feedback monitor.
- 10. (Original) The apparatus of claim 2 wherein the deposition probe further includes a tip.
- 11. (Original) The apparatus of claim 10 further comprising a humidity controller, the humidity controller selectively controlling the humidity of the air around the tip.
- 12. (Original) The apparatus of claim 2 wherein the control computer further comprises a stepper motor control card.
- 13. (Original) The apparatus of claim 12 wherein the humidity controller further comprises a dry gas source, a humidity source, and a gas flow monitor.

14.-16. (Canceled)

- 17. (Currently Amended) An apparatus for creating an array comprising:
 - a Z controller;
- a deposition probe operably attached to the Z controller, the deposition probe further comprising a tip;
 - an X, Y controller operably attached to the Z controller; and
- a deposition substrate operably affixed to the X, Y controller where the deposition substrate is selectively movable between a first position and a second position and wherein when the X, Y controller moves the deposition substrate to the second position the deposition substrate is positioned relative to under the tip.
 - 18. (Original) The apparatus of claim 17 further comprising:
- a control computer operably connected to the Z controller and the X, Y controller;
- a force feedback monitor operably affixed to the deposition probe and operably connected to the control computer; and
- a humidity controller operably affixed to the Z controller and operably connected to the control computer.
- 19. (Currently Amended) The apparatus of claim 20 17 further comprising an ozone source for cleaning the deposition probe.
 - 20. (Canceled.)

21. (New) An apparatus for creating a molecular array on a deposition substrate comprising:

a base;

a deposition probe removably and operably connected to the base;

an X, Y translation stage operably connected to the base wherein the X, Y translation stage is selectively positionable along the X axis, and the Y axis, the X, Y translation stage further comprising a loading substrate operably attached thereto and wherein the movement of the X, Y translation stage moves the loading substrate between a first position and a second position, the second position being located under the deposition probe; and

an X, Y controller operably connected to the base wherein the X, Y controller is selectively positionable along the X axis, and the Y axis, the X, Y controller further comprising a deposition substrate operably attached thereto and wherein the movement of the X, Y controller moves the deposition substrate between a first position and a second position, the second position being located under the deposition probe.

- 22. (New) The apparatus of claim 21 further comprising a control computer.
- 23. (New) The apparatus of claim 22 further comprising a humidity controller operably attached to the base wherein the humidity controller controls the humidity around the deposition probe.
- 24. (New) The apparatus of claim 23 wherein the humidity controller is operably connected to the control computer.
- 25. (New) The apparatus of claim 21 wherein the X, Y, Z controller has an approximately 200 nanometer spatial resolution along the Z axis.
- 26. (New) The apparatus of claim 25 wherein the X, Y, Z controller has an approximately 20 nanometer spatial resolution along the X and Y axes.
- 27. (New) The apparatus of claim 21 wherein the loading substrate further comprises one or more deposition materials deposited thereon.
- 28. (New) The apparatus of claim 21 further comprising an optical microscope operably attached to the base.

- 29. (New) The apparatus of claim 22 further comprising a force feedback monitor.
- 30. (New) The apparatus of claim 22 wherein the deposition probe further includes a tip.
- 31. (New) The apparatus of claim 30 further comprising a humidity controller, the humidity controller selectively controlling the humidity of the air around the tip.
- 32. (New) The apparatus of claim 22 wherein the control computer further comprises a stepper motor control card.
- 33. (New) The apparatus of claim 32 wherein the humidity controller further comprises a dry gas source, a humidity source, and a gas flow monitor.
 - 34. (New) An apparatus for creating an array on a substrate comprising: a base;
- a deposition probe operably attached to the base, the deposition probe further comprising a tip;
 - an X, Y translation stage operably attached to the base;
- a loading substrate operably affixed to the X, Y translation stage where the loading substrate is selectively movable into an operable position under the deposition probe;
 - an X, Y controller operably attached to the base;
- a deposition substrate operably affixed to the X, Y controller where the deposition substrate is selectively movable into an operable position under the deposition probe; and
- a humidity controller, the humidity controller selectively adjusting the humidity around the deposition probe, the X, Y translation stage, and the X, Y controller.